



Patent No.: 005920 USA/PMG/PCTRL

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
SHANMUGASUNDRAM et al. :  
Serial No. 09/943,383 : Group Art Unit: 2823  
Filed: August 31, 2001 : Examiner: William D. Coleman  
For: IN SITU SENSOR BASED CONTROL OF SEMICONDUCTOR PROCESSING  
PROCEDURE

**PETITION FOR EXTENSION OF TIME**

Honorable Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated May 28, 2004 for three months, from August 28, 2004 to November 28, 2004.

Please charge the \$980.00 fee to cover the cost of the extension to Deposit Account No. 08-0219. Any deficiency or overpayment should be charged or credited to Deposit Account No. 08-0219.

11/26/2004 GWORDDF1 00000105 080219 09943383  
01 FC:1253 980.00 DA

Respectfully submitted,

Wilmer Cutler Pickering Hale and Dorr LLP

Scott M. Alter  
Registration No. 32,879

The Willard Office Building  
1455 Pennsylvania Avenue, NW  
Washington, DC 20004  
202 942 8400  
Date: 11/24/04